Interferometry XVIII

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Editors

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Contents

vii Authors
ix Conference Committee
xiii Introduction

OCT AND QUANTITATIVE PHASE

9960 02 Real time parallel phase shift orthogonal polarization interference microscopy (Invited Paper) [9960-1]
9960 03 Non-contact investigation of the corneal biomechanics with air-puff swept source optical coherence tomography [9960-4]

WHITE LIGHT AND MICROSCOPY TECHNIQUES

9960 04 Are those bugs reflective? non-destructive biofilm imaging with white light interferometry (Invited Paper) [9960-6]
9960 05 Applications of model-based transparent surface films analysis using coherence scanning interferometry [9960-7]
9960 06 Reduction of batwing effect in white light interferometry for measurement of patterned sapphire substrates (PSS) wafer [9960-8]

AEROSPACE APPLICATIONS

9960 07 An overview of interferometric metrology and NDT techniques and applications for the aerospace industry (Invited Paper) [9960-9]

CHANDRA S. VIKRAM ADDRESS

9960 08 Is holography ready for yet another life? or make holography great again [9960-12]

OPTICAL ENGINEERING PLENARY SESSION

9960 09 The advanced LIGO detectors in the era of first discoveries (Plenary Paper) [9960-200]
### FRINGE ANALYSIS TECHNIQUES

| 9960 0A | Recent advances in phase shifted time averaging and stroboscopic interferometry (Invited Paper) [9960-13] |
| 9960 0B | Improved adjoin-list for quality-guided phase unwrapping based on red-black trees [9960-14] |
| 9960 0C | Dual-phase-shift schemes for internal-reflection noise reduction in a Fizeau interferometer [9960-15] |
| 9960 0D | Single and two-shot quantitative phase imaging using Hilbert-Huang Transform based fringe pattern analysis [9960-16] |

### ON THE FRINGE

| 9960 0E | Nano particle and defect detection: physical limit of state-of-the-art systems and novel measurement technique to improve upon this detection limit (Invited Paper) [9960-17] |
| 9960 0F | Subwavelength metrology of Al wire grating employing finite difference time domain method and Mueller matrix polarimeter [9960-18] |
| 9960 0G | A network of heterodyne laser interferometers for monitoring and control of large ring-lasers [9960-19] |
| 9960 0H | Effect of beam quality on tilt measurement using cyclic interferometer [9960-20] |

### CALIBRATION TECHNIQUES

| 9960 0I | The concept and implementation of smooth generic camera calibration (Invited Paper) [9960-21] |
| 9960 0J | Moire interferometry patterns for rotational alignment of structures [9960-22] |
| 9960 0K | Motion artifact reduction using hybrid Fourier transform with phase-shifting methods [9960-23] |
| 9960 0L | A non-linear piezoelectric actuator calibration using N-dimensional Lissajous figure [9960-24] |

### DEFLECTOMETRY AND FREEFORM METROLOGY

| 9960 0M | Testing the performance of freeform LED optics by gradient based measurement [9960-25] |
| 9960 0N | Determination of the paraxial focal length of strong focusing lenses using Zernike polynomials in simulation and measurement [9960-27] |
| 9960 0O | Line scanning deflectometry using a laser pico projector [9960-28] |
### FUTURE OF OPTICAL METROLOGY

9960 0P  Optical metrology in the conflict between desire and reality (Invited Paper) [9960-30]

### DIGITAL HOLOGRAPHY AND SPECKLE

9960 0Q  Digital holographic interferometry for characterizing deformable mirrors in aero-optics [9960-31]

9960 0R  Digital holographic interferometry based on hexa-lateral derivative and reflection holography [9960-32]

9960 0S  Two dimensional deformation vector analysis using speckle interferometry with same sensitivity in three directions [9960-33]

9960 0T  Single beam off-axis digital holography of laser driven jet using ring cavity [9960-34]

### GRATING AND FIBER SENSORS

9960 0U  Dynamic high pressure measurements using a Fiber Bragg Grating probe and an arrayed waveguide grating spectrometer [9960-35]

9960 0V  Adaptive grating interferometric sensor for NDE metrology in high energy electromagnetic environment [9960-36]

9960 0W  Mechanical design optimization of a single-axis MOEMS accelerometer based on a grating interferometry cavity for ultrahigh sensitivity [9960-37]

9960 0X  The analysis of temperature effect and temperature compensation of MOEMS accelerometer based on a grating interferometric cavity [9960-39]

### POSTER SESSION

9960 0Z  Optimizing multiplexing scheme in interferometric microscopy [9960-5]

9960 10  Improvement of spectrally resolved interferometry without direction ambiguity and dead zone [9960-40]

9960 11  Two-step phase shifting interferometry technique for evaluation of fatigue process zone parameters in notched specimens [9960-42]

9960 12  Spectral resolution measurement technique for Czerny-Turner spectrometers based on spectral interferometry [9960-43]

9960 13  A method for the analysis and data reduction from Hartmann and Shack-Hartmann tests [9960-44]

9960 14  Polarization characterization of liquid-crystal variable retarders [9960-45]
Analysis of a shearography device using a Wollaston prism and polarization phase shifting [9960-46]

Optical frequency comb profilometry based on a single-pixel phase imaging [9960-47]

Testing optical surfaces using two-frame phase-shifting interferometry [9960-50]

Orthogonal polynomials and global optimization based demodulation of two-shot fringe patterns [9960-53]

Self-mixing grating interferometer: theoretical analysis and experimental observations [9960-56]
Authors

Numbers in the index correspond to the last two digits of the six-digit citation identifier (CID) article numbering system used in Proceedings of SPIE. The first four digits reflect the volume number. Base 36 numbering is employed for the last two digits and indicates the order of articles within the volume. Numbers start with 00, 01, 02, 03, 04, 05, 06, 07, 08, 09, 0A, 0B...0Z, followed by 10-1Z, 20-2Z, etc.

Abdulhalim, I., 02
Addleman, R. Shane, 04
Adhikari, Achyut, 0F
Albertazzi, A. G., 0L, 15
Altintepe, Kadir, 0V
Arai, Y., 0S
Asundi, Anand, 0F
Bai, Jian, 0W, 0X
Barbarin, Y., 0U
Beghi, Alessandro, 0G
Belfi, Jacopo, 0G
Benedet, M. E., 15
Beverini, Nicolò, 0G
Binkele, Tobias, 0N
Bodnar, Michael, 0V
Borheya, George, 04
Bosi, Filippo, 0G
Brann, Michelle, 04
Bruce, Neil C., 14
Carelli, Giorgio, 0G
Chang, Yi-Wei, 06
Chen, Guanghua, 0T
Chien, Shih-Chen, 0O
Contreras Martínez, Ramiro, 12
Cruz-Santos, William, 0B
Cuccato, Davide, 0G
Desse, Jean Michel, 0R
Dev, Kapil, 0F
Di Virgilio, Angela, 0G
Donazzan, Alberto, 0G
Dovgalenko, George, 0V
Dresel, Thomas, 05
Fattin, A. V., 0L, 15
Fay, Martin F., 05
Ferreira, Carlos, 0D
Fleischmann, Friedrich, 0M, 0N
Furlong, Cosme, 0Q
Ganesan, A. R., 0H
Gantes Nuñez, Fco. Javier, 13
García-Monreal, Javier, 0D
Garduño Mejía, Jesús, 12
Georges, Marc P., 07
Grulkowski, Ireneusz, 03
Guo, Dongmei, 19
Han, Dandan, 0W, 0X
Han, Jae-Ho, 0Z
Hao, Hui, 19
Harding, Kevin, 0J
Hayasaki, Yoshio, 16
Heidari, Esmaeil, 0J
Henning, Thomas, 0M, 0N
Hess, Cecil F., 0Q
Hibino, Kenichi, 0C
Hilbig, David, 0M, 0N
Jaferzadeh, Keyvan, 02
Jiao, Xufen, 0W, 0X
Joenathan, C., 0H
Joo, Ki-Nam, 10
Józwik, Michał, 0A
Kaluzny, Bartłomiej, 03
Karnowski, Karol, 03
Kmet, Arkady B., 11
Koek, Wouter D., 0E
Kumagai, Toshiki, 0C
Languy, Fabian, 07
Larimer, Curtis, 04
Lefrancois, A., 0U
Li, Beiwen, 0K
Li, Jun, 0T
Li, Mu, 0T
Liang, Chao-Wen, 0O
Liu, Jun, 0T
Liu, Shengchun, 17, 18
Liu, Shouxian, 0T
Liu, Ziping, 0K
López-Garcia, Lourdes, 0B
López-Téllez, Juan M., 14
Lou, Shuqi, 0W, 0X
Lu, Qianbo, 0W, 0X
Luc, J., 0U
Luo, Zhenxiang, 0T
Maccioni, Enrico, 0G
Maczynska, Ewa, 03
Magne, S., 0U
Makhtar, Nabil, 16
Malacara Hernández, Daniel, 13
Malacara Hernández, Zacarías, 13
Micó, Vicente, 0D
Mizutani, Yasuhiro, 16
Montes, Iván, 14
Muravsky, Leonid I., 11
Nagaike, Yasunari, 0C
Naletto, Giampiero, 0G
Olchewski, François, 0R
Orolan, Antonello, 0G
Osmont, A., 0U
Osthash, Orest P., 11
Osten, W., 0P
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Discussion of Future Interferometry and Metrology Conferences
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Armando Albertazzi Gonçalves Jr., Universidade Federal de Santa Catarina (Brazil)

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Joanna Schmit, 4D Technology Corporation (United States)

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Digital Holography and Speckle
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Introduction

This is the eighteenth installment of the Interferometry conference – it has not always taken place in the current bi-annual format, so its beginnings reach back to the 1980s. For those of you who are old enough to remember, take a moment to re-play the reel of progress since; for those who are not, take a look at a yellow book with a three-digit number or download a scanned typewriter manuscript, marvel at the clumsy ways things were done then, and realize that the reason we are looking so much smarter today is because we are. All the mistakes we make (and share), all this apparent erring and bumbling leads to knowledge of how we might have begun in the first place – just one case and success story in point: the Laser Interferometer Gravitational-Wave Observatory. As such, we understand this book to be another chapter in the endless chronicle of trial, error, and improvement.

A trial with this conference is that this time we do not have the two subconferences “Techniques and Analysis” and “Applications” but rather a combination of the two. We have had fewer contributions than usual; this may have to do with the late date for the meeting, which for many has been after the summer break – but possibly also with confusion as to what the new format means and where to place contributions. As at the time of writing, we are looking forward to the discussion with you about the future and format of the conference.

There have been unusually many withdrawals this time, due to various reasons, ranging from visa issues to clearance for publication. The Chairs would like to encourage potential authors to start such foreseeable processes early – being focused on the scientific results, it is easy to forget about the more mundane things around attending a conference. Also, from experience, it is a good idea to have at least part of the results already “in the bag” – there is not one among us who has never experienced the last-minute rush that comes with trying to meet a deadline that involves the rest of the experimental program besides the writing process.

Having said that, we do applaud the authors who decided not to rush things along just for the sake of the deadline, and we are very happy with the quality of the material we did receive. As usual, it has gone through a peer-review process to ensure we all get a conference volume that will be useful as a reference for many years. The featured authors, from 18 countries, have brought inspiring papers to this forum, which we are very pleased to present in this book. It contains 44 papers presented at the SPIE’s 61st Annual Meeting in San Diego on August 30 –September 1, 2016. Thirty-two of these papers were presented orally.
When thinking of interferometry, the first thing coming to mind is of course the phase of wavefronts, as used so beautifully in non-destructive testing and holography. One feature of this conference is the Chandra S. Vikram Address, a look upon the past (and future) of holography, given by the 2016 winner of the Vikram Award, James D. Trolinger. We plan to continue highlighting winners of this award at future conferences.

Of course, the wavefront measurement can also gainfully be coupled with other properties of light, such as polarization and coherence, whose manipulation and use are featured in a number of exciting applications. We have mentioned LIGO above, and part of this year’s Plenary program is an overview of the progress and observations made with the advanced version of the instrument, which from the outside looks like just a giant Michelson interferometer, but requires a very large number of tweaks to achieve a level of sensitivity that even Einstein could not imagine.

While LIGO is surely the cover story of this year, we have a number of other contributions on pushing the boundaries of metrology and detection methods, as well as further progress reports on the timeless topic of advanced fringe generation and analysis. Calibration methods are the foundation of quantitative metrology, and this topic is also covered by several authors from different areas of research. A useful complement to interferometry is deflectometry, using geometrical optics for measurements with very high dynamic range, and some practical applications of the technique are featured in this volume.

Further classical topics such as speckle interferometry and digital holography are also represented – just like any other topic, they started as tentative new ideas several decades ago and are now serving as an established base for many initially unusual ideas of today. Finally, we have a section on multiple-beam interferometers, viz., very sensitive grating sensors, whose principles are also well known and whose use continues to spread.

The range of topics presented reflects the versatility and ubiquity of optical metrology – like the photon itself, it pervades our world, and its importance is most easily recognized in its absence.
During our last conference in 2014, we had once more a very lively and fun Fringe Art competition with several rounds of voting, choosing our favorite fringe patterns from those brought along by attendees. The origin of phenomena submitted to the Fringe Art Competition spanned the range from mouse neurons and ear drum vibrations to more common objects such as vibrating cantilevers, moiré, diffraction patterns, and waves caused by wind on San Diego harbor and Coronado beach.

The image ultimately selected as the favorite was submitted by Dr. Jake Beverage, then at Zygo Corp., Middlefield, CT USA (now with Arizona Optical Systems, Tucson, AZ USA). The image is of a cutting tool covered with a thin oil film, viewed through the ZYGO Nexview™ interference microscope with color imaging. The imaging area is 0.9 mm x 0.9 mm. In the image you can see both the faint interference fringes as well as the thin film interference.

Let us close with a sincere thank-you to SPIE, the program committee, the authors, and everyone attending this eighteenth Interferometry conference. As we have said last time, metrology never goes out of style, and a few things deemed too hard or even impossible even two years ago have been demonstrated now, encouraging further demands for the (almost) impossible (again, who of us has not experienced this?!!). Besides the incremental broadening of scopes and sharpening of sensitivities, there were also “the usual surprises”, i.e. innovative uses opening up new ways of thinking. We are very pleased that SPIE continues to support and provide this forum for us.

Until next time!

Katherine Creath
Jan Burke
Armando Albertazzi Gonçalves Jr.